



Application No.: 10/628,803

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Dated: August 3, 2005

Signature:

(Michael R. Huff)

Docket No.: 29936/39432

Docket No.: 29936/39432  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Sung Hoon Lee

Application No.: 10/628,803

Confirmation No.: 4537

Filed: July 28, 2003

Art Unit: 1765

For: METHOD OF FORMING ISOLATION FILM  
OF SEMICONDUCTOR DEVICE

Examiner: Lan Vinh

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Ammdmetn  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Commissioner:

Amendments to the specification appear on page 2 of this paper.

Amendments to the claims and a complete listing of the claims begin on page 4 of this paper.

Remarks in support of the allowability of this application begin on page 6 of this paper.